

Category: Plasma components

Technical drawing of the 3000 series pump assembly showing dimensions: 271, 288.2, 15.72, and 76.4.



ADDITIONAL INFORMATION

Typ	Radical plasma source (Remote Plasma Source)
Process	Etching & Deposition
Output Connection Type	
Dielectric material	Sapphire
Mains voltage nominal [V]	230 / 208
Output Power CW [W]	3000
Frequency [MHz]	2450